



Serial No.: 09/905,633
Inventors: Kelly T. Hurley

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Kelly T. Hurley

Serial No.: 09/905,633

Filed: 07/13/2001

For: **METAL LOCAL INTERCONNECT SELF-
ALIGNED SOURCE FLASH CELL**

§ Group Art Unit: 2823
§ Examiner: Nguyen, Khiem D.
§ Atty. Docket: 2000-0100.00
§ Paper No. * 8
§

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Certificate of Mailing (37 C.F.R. §1.8)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, on the date below:

10/23/03

Yana Shafford

Signature

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

In compliance with the duty of disclosure under 37 CFR §1.56, Applicant respectfully requests entry of this Information Disclosure Statement, and that the references listed on the attached Form PTO-1449 be considered by the Examiner and made of record. A copy of any reference required for its consideration is enclosed.

In accordance with 37 CFR §1.97(b), this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possible material information as defined in 37 CFR §1.56(a) exists.

RECEIVED
OCT 29 2003
TC 2800 MAIL ROOM

The following reference is submitted for the Examiner's review:

U.S. Patent Documents

Document No.	Date	Inventor
5,731,242	03/1998	Parat et al.
6,080,624	06/2000	Kamiya et al.
6,271,087	08/2001	Kinoshita et al.

As this Information Disclosure Statement is being submitted with the Request for Continued Examination, no fee is due. However, the Commissioner is authorized to charge any required fee to Micron Technology Inc. Deposit Account No.13-3092, Order No. 2000-0100.00.

If there are any matters which may be resolved or clarified through telephone interview, the Examiner is respectfully requested to contact Applicant's undersigned agent at the number indicated.

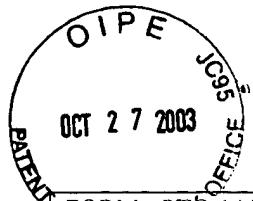
* * * *

A Form PTO-1449 is enclosed herewith.

Respectfully submitted,



David J. Paul
Agent for Applicant
Registration No. 34,692
Micron Technology, Inc.
PO Box 6
Boise, ID 83707-0006
Ph: (208) 368-4515
FAX: (208) 368-5606



Sheet 1 of 1

FORM: PTO-1449
(REV. 7-80)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

Atty Docket No:
2000-0100.00

Serial No:
09/905,633

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(37 CFR 1.98(b))

(use several sheets if necessary)

Applicant:
Micron Technology, Inc.

Filing Date: 07/13/2001 Group: 2823

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass
AA	5,731,242	03/1998	Parat et al.	438	586
AB	6,080,624	06/2000	Kamiya et al.	438	257
AC	6,271,087	08/2001	Kinoshita et al.	438	258
AD					
AE					
AF					
AG					
AH					
AI					
AJ					
AK					

1C 2800 MAIL ROOM
06/29/2003
RECEIVED

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No
AL						<input type="checkbox"/>	<input type="checkbox"/>
AM						<input type="checkbox"/>	<input type="checkbox"/>
AN						<input type="checkbox"/>	<input type="checkbox"/>
AO						<input type="checkbox"/>	<input type="checkbox"/>
AP						<input type="checkbox"/>	<input type="checkbox"/>
AQ						<input type="checkbox"/>	<input type="checkbox"/>

Initial

OTHER ART (including author, title, date, pertinent pages, etc.)

AR							
AS							
AT							

Examiner:

Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication with applicant.